

**INFORMATION DISCLOSURE STATEMENT**

Applicant : Masahaiko Nakamori et al.  
App. No : 10/536,621  
Filed : May 26, 2005  
For : POLISHING PAD AND METHOD OF  
PRODUCING SEMICONDUCTOR  
DEVICE  
Examiner : MacArthur, Sylvia R.  
Art Unit : 1792  
Conf No. : 9275

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 2 references, of which 2 are enclosed/submitted.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing date of a Notice of Allowance.

**CERTIFICATION UNDER 37 C.F.R. § 1.97(c)(1)**

I hereby certify that each item of information contained in this Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

Thus, no fee is required as set forth in 37 C.F.R. § 1.97(c), however, the Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: January 5, 2011

By: /daniel altman/

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